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MOSER PATTERSON SHERIDAN

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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: Seutter et al.

Case: AMAT/5192/ISM/CORE MCVD/SB

Serial No.: 09/776,329

Filed: February 2, 2001

Examiner: Toniae M. Thomas Group Art Unit: 2822

Title: FORMATION OF A TANTALUM-NITRIDE LAYER

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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MAY 02 2003

SIR:

TECHNOLOGY CENTER 2800

AMENDMENT

In response to the Office Action dated February 4, 2003 (Paper No. 7),
please amend the above-identified application as indicated..